IE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Michael L. McSwiney et al.

Art Unit: 1792

Serial No.:

10/764,193

Examiner:

Renee R. Berry

Filed:

January 23, 2004

Atty Docket: ITL.1056US

P17793

999999999999

For:

Forming a Silicon

Nitride Film

Assignee:

Intel Corporation

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REPLY TO OFFICE ACTION

Sir:

In response to the office action mailed October 9, 2007, please amend the abovereferenced patent application as follows:

Date of Denosit: <u>January 7, 2008</u>

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class** man with sufficient postage on the date indicated above and is to the Commissioner for

Cynthia L. Hayden